

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Hidemi Takasu

Serial No .:

09/212,915

Examiner: M. Estrada

Filed

December 16, 1998

Group Art Unit: 2823

For

PROCESS FOR FABRICATING A SEMICONDUCTOR DRIVE

AMENDMENT

I hereby certify that this paper is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Box AF, P.O. Box 1450, Alexandria, VA 22313-1450, on:

May 19, 2003

Date of Deposit

52,017

PTO Reg. No.

Assistant Commissioner for Patents Box AF

P.O. Box 1450

Alexandria, VA 22313-1450

May 19, 2003
Date of Signature ECHNOLOGY CENTER 2800

Sir:

Please Do not Enter

In response to the Examiner's Action mailed November 18, 2002 please amend the above-identified application as follows:

1

In the Claims:

Please amend claim 1 in the following manner:

NY02:441654.1